

<b>Notice of References Cited</b>	Application/Control No. 09/751,858		Applicant(s)/Patent Under Reexamination SANTOS ET AL.	
	Examiner Susanna M. Diaz		Art Unit 3692	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Susan S. Baum and Cheryl M. O'Donnell, An Approach to Modeling Labor and Machine Down Time in Semiconductor Fabrication, Proceedings Of The 23rd Conference On Winter Simulation, Phoenix, Arizona, ISBN:0-7803-0181-1, Pp. 448-54,1991.			
	V	Alan Dix and Geoffrey Ellis, Starting Simple - Adding Value to Static Visualisation Through Simple Interaction, Proceedings Of The Working Conference On Advanced Visual Interfaces, L'Aquila, Italy, Pp. 124 - 34,1998.			
	W				
	X				

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.